

Intrinsic Piezoelectricity in Two-Dimensional Materials

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ABSTRACT: We discovered that many of the commonly studied two-dimensional monolayer transition metal dichalcogenide (TMDC) nanoscale materials are piezoelectric, unlike their bulk parent crystals. On the macroscopic scale, piezoelectricity is widely used to achieve robust electromechanical coupling in a rich variety of sensors and actuators. Remarkably, our density-functional theory calculations of the piezoelectric coefficients of monolayer BN, MoS₂, MoSe₂, MoTe₂, WS₂, WSe₂, and WTe₂ reveal that some of these materials exhibit *stronger* piezoelectric coupling than traditionally employed bulk wurtzite structures. We find that the piezoelectric coefficients span more than 1 order of magnitude, and exhibit monotonic periodic trends. The discovery of this property in many two-dimensional materials enables active sensing, actuating, and new electronic components for *nanoscale* devices based on the familiar piezoelectric effect.



SECTION: Physical Processes in Nanomaterials and Nanostructures

N anoelectromechanical systems (NEMS) and nanoscale electronics are the final frontier in the push for miniaturization that has been among the dominant themes of technological progress for over 50 years. Enabled by increasingly mature fabrication techniques, low-dimensional materials including nanoparticles, nanotubes, and (near-)atomically thin sheets have emerged as the key components for the next generation of "active nanostructure" NEMS devices including radios,¹ switches,^{2–4} tweezers,⁵ as well as mass,⁶ gas,⁷ pressure,^{8,9} and displacement sensors.¹⁰ The traditional field effect transistor paradigm has also been extended to nanotubes,¹¹ graphene,¹² and monolayer MoS₂.¹³

All of the NEMS devices mentioned require some type of static or dynamic mechanical displacement that is electrically sensed, dynamically controlled, or both. Piezoelectric materials have historically been used in many applications requiring electromechanical coupling, and nanoscale devices also stand to gain additional capabilities, simplicity, and autonomous operation through integration of piezoelectric materials. For instance, recent experimental work utilizes piezoelectric microor nanowires as piezo-phototronic facilitators for light emission¹⁴ or as the active component of efficient nanogenerators that convert mechanical energy into electricity.^{15,16} Piezoelectricity may also be used to generate charge carriers¹⁷ or construct relays¹⁸ in an electronics context. In a rapidly emerging field termed (nano)piezotronics, the controllable charges and electric fields generated by piezoelectrics have been used in several prototype devices such as field effect transistors, piezoelectric-gated diodes, and sensors.¹⁹

Given these bright prospects for piezoelectricity as an enabler of nanoscale technology along with the explosive advances in fabrication methods, it becomes natural to inquire whether atomically thin sheet materials such as graphene can also be used as piezoelectric building blocks. Recently, we and other researchers have predicted using computational models that graphene can be rendered piezoelectric through adatom adsorption²⁰ or introduction of specific in-plane defects,²¹ paving the way to a strong miniaturization and site-specific engineering of familiar piezoelectric technology using graphene. We now report that a family of widely studied atomically thin sheet materials are in fact *intrinsically* piezoelectric, elucidating an entirely new arsenal of "out of the box" active components for NEMS and piezotronics.

Despite the fact that fullerenes and graphene have made carbon allotropes the most studied of all nanomaterials, graphite is by no means the only layered parent crystal that is amenable to isolation of monolayer sheets. Currently, the most prominent of these other parent crystals are hexagonal boron nitride (h-BN or 2H-BN)²² and a family of trigonalprismatically coordinated transition metal dichalcogenide (TMDC) crystals. In keeping with prior literature, we refer to these crystals as 2H-TMDCs, where the 2H prefix is Ramsdell notation for the bulk stacking sequence (two-layer periodic) and the unit cell's basal plane shape (hexagonal).²³ These crystals include, but are not limited to, MoS_2 (monolayers first isolated in 1986),^{22,24} WS_2 ,^{25,26} and NbSe₂.^{22,26} When viewed from the top, the 2H structure of the above materials is a honeycomb structure where adjacent sites are occupied by two alternating species (Figure 1a,b). The difference between h-BN and the 2H-TMDC monolayer structure is that h-BN is atomically thin (Figure 1c), whereas one 2H-TMDC monolayer sublattice contains two chalcogenide atoms at z = h and z = -h, and the other sublattice contains a transition metal at z = 0 (Figure 1d).

For a material to be piezoelectric, it must not be centrosymmetric (i.e., possess a point through which a spatial inversion leaves the structure invariant).²⁷ Due to their experimentally observed antiparallel stacking sequence, the

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Figure 1. Monolayer top view geometry of (a) boron nitride (h-BN) and (b) trigonal prismatic molybdenum disulfide (2H-MoS₂) where B atoms are red, N atoms are blue, Mo (transition metal) atoms are silver, and S (chalcogenide) atoms are yellow. The axes and direction of piezoelectric polarization are labeled, and the hexagonal primitive cell is highlighted in blue. The orthorhombic unit cell used in the DFT simulations is labeled in yellow. (c) Side view of the atomically thin h-BN monolayer. (d) Side view of the 2H-MoS₂ monolayer, showing out-of-plane structure.

Table 1. Bulk Experimental Lattice Constant a_0 , Calculated Monolayer Lattice Constant a_0 , Monolayer Chalcogenide Height h, and Monolayer Electronic Band Gap E_{gap} of Different 2D Materials Calculated Using DFT/GGA^a

material	bulk a_0 (Å)	a_0 (Å) calc.	h (Å) calc.	$E_{\rm gap}$ (eV) calc.	pseudopotentials
h-BN	2.50 ²⁸	2.51		4.68	Vanderbilt (n-B)
$2H-MoS_2$	3.16 ²⁹	3.19	1.57	1.67	PAW (sp-n-Mo, n-S)
2H-MoSe ₂	3.29 ²⁹	3.33	1.67	1.43	PAW (sp-n-Mo, n-Se)
2H-MoTe ₂	3.52 ²⁹	3.59	1.82	1.05	norm-conserving ³²
2H-WS ₂	3.15 ²⁹	3.19	1.57	1.81	Vanderbilt (n-W)
2H-WSe ₂	3.29 ²⁹	3.32	1.67	1.53	Vanderbilt (n-W)
2H-WTe ₂		3.56	1.82	1.05	norm-conserving ³²
2H-NbSe ₂	3.45 ²⁹	3.47	1.68	Metallic	Vanderbilt (sp-n-Nb)
2H-TaSe ₂	3.43 ²⁹	3.47	1.67	Metallic	Vanderbilt (sp-n-Ta)

^aThe atomic pseudopotentials used to simulate the ions include Vanderbilt (ultrasoft), norm-conserving, and projector augmented-wave (PAW) types. Some pseudopotentials include a nonlinear core (n), an s&p-semicore (sp), or d-semicore (d) corrections.

bulk stacked-layer h-BN and 2H-TMDC crystals *are* centrosymmetric.^{28,29} At first glance, the presence of centrosymmetry makes these crystals a seemingly fruitless place to look for piezoelectricity. However, it can be seen from Figure 1 that a *single* h-BN or 2H-TMDC monolayer *does not* have an inversion center. Lack of centrosymmetry has the mathematical consequence that all odd-rank tensor properties, including the third-rank piezoelectric tensor, may be nonzero.²⁷ Hence, a noncentrosymmetric crystal that is found to be electrically insulating is a candidate piezoelectric, regardless of whether it is a one-, two- or three-dimensional structure. This is also the case, for example, in BN nanotubes.³⁰ The exciting prospect of intrinsically piezoelectric monolayer materials and their potential ramifications for technology in the nanoscale regime has prompted us to *quantitatively* map the piezoelectric and elastic properties of a collection of candidate materials.

We use density functional theory (DFT) at the generalized gradient approximation (GGA) level of theory to calculate the piezoelectric and elastic stiffness coefficients. Piezoelectric properties are associated with ground electronic state changes in polarization, for which DFT generally provides a reasonable description. For example, prior work on the piezoelectric properties of GaN shows agreement with experimental measurements to within approximately 20%.³¹ We use the nonprimitive orthorhombic unit cells shown in Figure 1 as the computational unit cell for all calculations. The hexagonal lattice constant a_0 and atomic positions were allowed to relax subject to zero pressure following the convergence criteria listed in the Computational Methods section.

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The optimized geometries and calculated band gap energies of h-BN and several 2H-TMDCs are summarized in Table 1. Note that BN, MoS_2 , $MoSe_2$, $MoTe_2$, WS_2 , $NbSe_2$, and $TaSe_2$ have been experimentally isolated in monolayer form.^{26,33} We find $NbSe_2$ and $TaSe_2$ to be metallic and hence not piezoelectric. The monolayer 2H-TMDCs containing Mo or W are found to be insulating. The semilocal DFT-calculated monolayer MoS_2 band gap of 1.67 eV is in reasonable agreement with the experimental value of 1.9 eV.³⁴ We find the lattice parameters a_0 and h to be correlated primarily to the chalcogenide present in the 2H-TMDC monolayers and largely independent of the transition metal atom type.

It should be stressed that 2H is just one of the possible TMDC structures that are experimentally stable or metastable. For example, monolayers of MoS₂, WS₂, and MoSe₂ obtained through water-based lithium intercalation are reported to exhibit a distorted octahedral structure.^{35,36} Other authors

report using a different solution-based process²⁶ and mechanical exfoliation³⁷ to isolate MoS₂ monolayers exhibiting Raman spectra consistent with the 2H structure. Bulk MoS₂, MoSe₂, MoTe₂, WS₂, and WSe₂ have all been observed in trigonal prismatic (2H) form,²⁹ but bulk MoTe₂ has also been observed as a distorted octahedral structure.³⁸ The dominant structure of bulk WTe₂ is distorted octahedral.³⁸ Piezoelectric properties of the metastable 2H form of WTe₂ are still studied in this letter for the purpose of direct comparison with the other structures.

Motivated by the overall scarcity of experimental structural information on monolayers, Table 2 lists our DFT calculations

Table 2. Calculated Differences in Ground-State Energy PerFormula Unit for the Octahedral and Distorted-OctahedralStructures, Referenced to the Trigonal Prismatic 2HStructure of the Studied TMDC Insulators^a

material	octahedral (eV)	dist. octahedral (eV)
MoS ₂		0.55
MoSe ₂		0.33
MoTe ₂		0.10
WS ₂	0.92	0.54
WSe ₂	0.78	0.30
WTe ₂	0.57	-0.14

^aStructural optimization of octahedral Mo-containing monolayers resulted in the distorted octahedral structure. Structures are surrounded by vacuum (i.e. freely suspended).

of the relative energy differences for the 2H, octahedrally coordinated (i.e., The PtS_2 structure),²⁹ and distorted octahedral monolayer structures of TMDCs in vacuum. The trigonal prismatic 2H structure is found to be lowest in energy for all materials except WTe₂, where the distorted octahedral structure is found to be lowest in energy. We find that the distorted octahedral structures are metallic, ruling out in-plane piezoelectricity.

In order to obtain the elastic stiffness coefficients of the candidate piezoelectrics, the total energy per unit area $u(\varepsilon_{11},\varepsilon_{22})$ is calculated on a 7 × 7 grid with strain components ranging from -0.006 to 0.006 in steps of 0.002. Atomic positions are relaxed at each strain state to generate the so-called relaxed-ion coefficients that are expected to be experimentally observable. Another calculation is performed at each strain state with scaled atomic positions (i.e., no atomic relaxation) to yield so-called clamped-ion coefficients. Planar elastic stiffness coefficients for both cases C_{11} and C_{12} are obtained by fitting the obtained $u(\varepsilon_{11},\varepsilon_{22})$ to eq 1:

$$u(\varepsilon_{11}, \varepsilon_{22}) = \frac{1}{2}C_{11}(\varepsilon_{11}^2 + \varepsilon_{22}^2) + C_{12}\varepsilon_{11}\varepsilon_{22}$$
(1)

Clamped- and relaxed-ion elastic coefficients are summarized in Table 3. For the 2H-TMDC materials, the Poisson ratio ν_{\perp} that governs out-of plane variation of *h* in response to an inplane strain according to $\Delta h/h = -\nu_{\perp}(\varepsilon_{11} + \varepsilon_{22})$ is obtained directly from the relaxed structures. All calculated elastic coefficients satisfy the Born stability criteria for crystals possessing hexagonal symmetry.^{27,39} The ab initio-calculated C_{11} and C_{12} values for monolayer h-BN and monolayer 2H-MoS2 are within approximately 10% of available elastic coefficients experimentally measured in the bulk phase, after converting the latter to a per-monolayer two-dimensional (2D) form.^{40,41}

Table 3. Calculated Clamped-Ion and Relaxed-Ion
Components, C_{11} and C_{12} , of the Elastic Tensor for Each
Piezoelectric Monolaver at the DFT/GGA Level of Theory

	clamped-ion		r		
material	C_{11} (N/m)	C_{12} (N/m)	C_{11} (N/m)	C_{12} (N/m)	ν_{\perp}
h-BN	300	53	291	62	
$2H-MoS_2$	153	48	130	32	0.34
$2H-MoSe_2$	131	39	108	25	0.35
2 H-MoTe $_2$	101	32	80	21	0.37
2H-WS ₂	170	56	144	31	0.36
$2H-WSe_2$	147	40	119	22	0.36
$2H-WTe_2$	116	31	89	15	0.39
^{<i>a</i>} The Poisson ratio ν_{\perp} that governs elastic relaxations in <i>h</i> is also calculated where relevant.					

The linear piezoelectric effect in a flat and 2D material can be viewed as a first-order coupling between surface polarization (P_i) or the macroscopic electric field (E_i) , and stress (σ_{jk}) or the strain (ε_{jk}) tensors, where *i*, *j*, $k \in \{1,2,3\}$, with 1, 2, and 3 corresponding to *x*, *y*, and *z*, respectively. The effect can be described using the third-rank piezoelectric tensors d_{ijk} , e_{ijk} , and their respective Maxwell relations:²⁷

$$d_{ijk} = \left(\frac{\partial P_i}{\partial \sigma_{jk}}\right)_{E,T} = \left(\frac{\partial \varepsilon_{jk}}{\partial E_i}\right)_{\sigma,T}$$
(2)

$$e_{ijk} = \left(\frac{\partial P_i}{\partial \varepsilon_{jk}}\right)_{E,T} = -\left(\frac{\partial \sigma_{jk}}{\partial E_i}\right)_{\varepsilon,T}$$
(3)

It can be shown that d_{ijk} and e_{ijk} are related via the elastic stiffness tensor, C_{ijkl} . Both monolayers of h-BN and of 2H-TMDC belong to the D_{3h} ($\overline{6}m2$) point group. This symmetry places restrictions on the magnitude and uniqueness of the piezoelectric tensor coefficients. In the case of D_{3h} , only one *d*-and one *e*-coefficient need to be calculated. Employing Voigt notation to limit the number of indices, the only allowed nonzero piezoelectric *d*-coefficients are²⁷

$$d_{111} = d_{11}$$

$$d_{122} = d_{12} = -d_{11}$$

$$d_{212} = d_{221} = \frac{1}{2}d_{26} = -d_{11}$$
(4)

Similar, but slightly different relations hold for the nonzero *e*-coefficients:

$$e_{111} = e_{11}$$

$$e_{122} = e_{12} = -e_{11}$$

$$e_{212} = e_{221} = e_{26} = -e_{11}$$
(5)

All in-plane elastic and piezoelectric properties of D_{3h} monolayers are fully determined by only three coefficients because d_{11} and e_{11} are related as follows:

$$e_{11} = d_{11}(C_{11} - C_{12}) \tag{6}$$

In order to complete the picture, we calculate the change in polarization along *x* per unit cell using the geometric phase approach of King-Smith and Vanderbilt^{42,43} implemented in Quantum Espresso.⁴⁴ The clamped- and relaxed-ion piezo-electric e_{11} -coefficients are subsequently obtained by least-squares fitting of the polarization change per unit area to eq 7:

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$$P_{1}(\varepsilon_{11}, \varepsilon_{22} = 0) - P_{1}(\varepsilon_{11} = 0, \varepsilon_{22} = 0) = e_{11}\varepsilon_{11}$$
(7)

Using eq 7, we calculate the relaxed-ion (clamped-ion) d_{11} by knowledge of the relaxed (clamped) results for e_{11} , C_{11} and C_{12} .

Figure 2 illustrates the direct calculations of the piezoelectric e_{11} -coefficients and Table 4 gives the calculated d_{11} values. The



Figure 2. Applied uniaxial strain along the *x*-axis results in a change in polarization along the same axis for monolayer h-BN and MS_2 where M = Mo or W. Atom positions are relaxed under uniaxial strain to obtain the relaxed-ion piezoelectric coefficient determined by the slope of the line.

Table 4. Calculated Clamped-Ion and Relaxed-Ion	
Piezoelectric Coefficients, e_{11} and d_{11}^{a}	

	clamped-ion		relaxed-ion		
material	$(10^{-10}$ C/m)	<i>d</i> ₁₁ (pm/V)	$(10^{-10}$ C/m)	<i>d</i> ₁₁ (pm/V)	
h-BN	3.71	1.50	1.38	0.60	
2H-MoS ₂	3.06	2.91	3.64	3.73	
2H-MoSe ₂	2.80	3.05	3.92	4.72	
2H-MoTe ₂	2.98	4.33	5.43	9.13	
2H-WS ₂	2.20	1.93	2.47	2.19	
2H-WSe ₂	1.93	1.80	2.71	2.79	
2H-WTe ₂	1.60	1.88	3.40	4.60	
graphene + Li			$0.15 \ (e_{31})^{20}$	$0.55 \ (d_{31})^{20}$	
bulk α -quartz				2.3 $(d_{11})^{45}$	
bulk GaN (wurtzite)				$3.1 (d_{33})^{46}$	
bulk AlN (wurtzite)				5.1 $(d_{33})^{46}$	

^{*a*}Predicted 31-coefficients for piezoelectric lithium-doped monolayer graphene and experimentally measured *d*-coefficients of popular bulk piezoelectrics α -quartz, GaN, and AlN are listed for comparison.

calculated relaxed-ion d_{11} -coefficients, especially those for the 2H-TMDC monolayers, compare favorably with coefficients of frequently used bulk piezoelectrics such as α -quartz ($d_{11} = 2.3$ pm/V),⁴⁵ wurtzite GaN ($d_{33} = 3.1$ pm/V),⁴⁶ and wurtzite AlN ($d_{33} = 5.1$ pm/V).⁴⁶ The clamped-ion e_{11} coefficient for h-BN is in good agreement with the value of 3.57×10^{-10} C/m, calculated earlier by Naumov et al.⁴⁷ The entire range of calculated relaxed-ion d_{11} -coefficients spans more than 1 order of magnitude. Nevertheless, all the obtained relaxed-ion d_{11} -and e_{11} -coefficients *exceed* those predicted for e_{31} -/ d_{31} -type

We find that the relaxed-ion e_{11} and d_{11} coefficients in the 2H-TMDC monolayers obey a periodic trend. WS₂ possesses the smallest piezoelectric effect, and moving upward in group 6 (transition metal) or downward group 16 (chalcogenide) enhances the magnitude of the effect until MoTe₂, having the largest coefficient, is reached. The trend is more dramatic in d_{11} because there also are trends in C_{11} and C_{12} that serve to amplify the trend in e_{11} . Figure 3 summarizes all the periodic trends strictly obeyed by our data.



Figure 3. Trends in relaxed-ion structural, elastic, and piezoelectric properties of 2H-MX₂, where M = Mo or W, and X = *S*, Se, or Te. The relaxed-ion d_{11} coefficient values are listed as an example.

Here we have shown, for the first time, that many of the 2D materials at the center of considerable research focus are in fact piezoelectric. Because of its surprising magnitude, the piezoelectric effect in these 2D materials is much more than a theoretical curiosity. We are optimistic that this piezoelectric effect can be quantified in a relatively straightforward experiment on TMDC flakes. For example, because of transition metals' strong interaction with X-ray radiation, monolayer flakes may be utilized for precise measurement of field-induced strain. Conversely, experiments can be envisioned where an applied strain is directly correlated to a measurable voltage across a finite-size flake, turning the monolayer sheet into a highly sensitive strain gauge. We expect the piezoelectric properties of these materials to provide new platforms for electronic and piezotronic devices, and enable previously inaccessible avenues for sensing and control at the nanoscale.

COMPUTATIONAL METHODS

We used DFT implemented within the Quantum-ESPRESSO 5.0 ab initio software package.⁴⁴ Depending on the material simulated, ion cores were treated using ultrasoft Vanderbilt,⁴⁸ norm-conserving,⁴⁹ and projector augmented-wave⁵⁰ pseudo-potentials, as listed in Table 1. Electron exchange and correlation effects were described using the generalized-gradient-corrected Perdew-Burke-Ernzerhof (PBE) approximation.⁵¹ Periodic boundary conditions were employed in all three

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dimensions using an orthorhombic unit cell containing either two boron atoms and two nitrogen atoms for BN, or four chalcogenide atoms and two transition metal atoms for the TMDC systems. Note the hexagonal primitive cell was not used in order to align the direction of polarization along one of the lattice vectors (i.e., the *x*-axis). A 30 Å cell height was used in the *z*-direction to prevent periodic images from interacting with each other. The electronic wave function was expanded in a plane wave basis set with an energy cutoff of 60 Ry. The charge density was expanded in a basis set with a 500 Ry plane wave cutoff. Brillouin zone sampling was done using a Monkhorst-Pack mesh⁵² of $14 \times 14 \times 1$ k-points. All ionic relaxations and cell optimizations were performed using a threshold of 10^{-4} Ry/Bohr for the force and 10^{-6} Ry for the unit cell energy.

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Notes

The authors declare no competing financial interest.

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